Filed: May 30, 2001


## For: SILICON-TYPE THIN FILM FORMATION

COMMISSIONER FOR PATENTS
Mail Stop: AF
P.O. Box 1450

Alexandria, VA 22313-1450
Sir:
Transmitted herewith is a Response After Final Action in the above-identified application.
X No additional fee is required.
The fee has been calculated as shown below


* If the entry in Column 2 is less than the entry in Column 4, write " 0 " in Column 5.
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write " 3 " in this space.
$\square{ }^{\circ}$ Verified Statement claiming small entity status is enclosed, if not filed previously.
$\qquad$ is enclosed.

Charge \$ $\qquad$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

X Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 061205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205.

X A check in the amount of $\$ 110.00$ to cover the fee for a one-month extension is enclosed.

A check in the amount of $\$$ $\qquad$ to cover the Information Disclosure Statement fee is enclosed.

X Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 2182100. All correspondence should continue to be directed to our address given below.

FITZPATRICK, CELLA, HARPER \& SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

Form \#120

NY_MAIN 364886v1

